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Simulating Plasmon Effect in Nanostructured OLED Cathode Using COMSOL Multiphysics

Leiming Wang

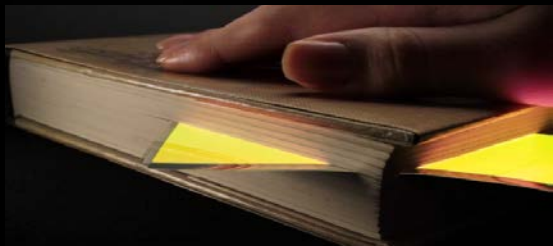
Konica Minolta Laboratory USA Inc.

10/08/2015

Konica Minolta OLED lighting



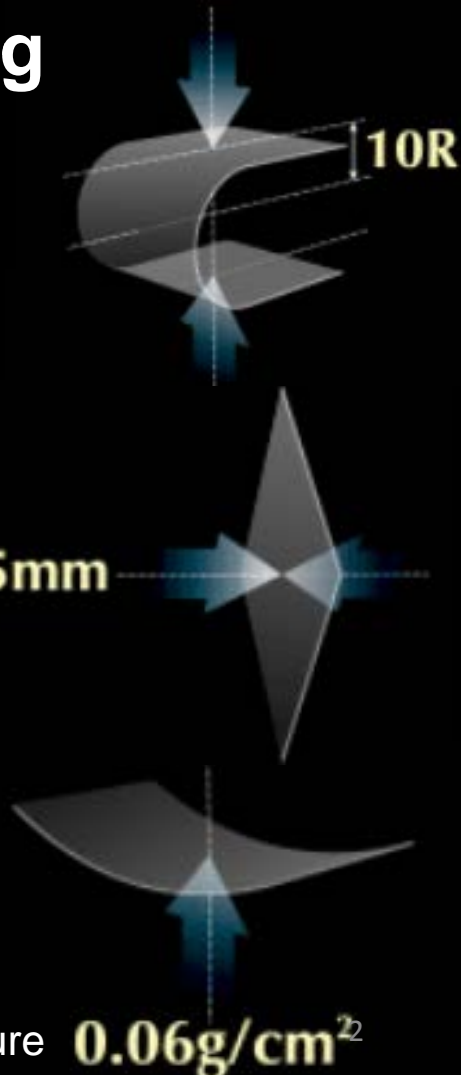
Flexible



Thin



Lightweight



One piece of cutting-edge technology creates the future **0.06g/cm²**

Konica Minolta OLED lighting

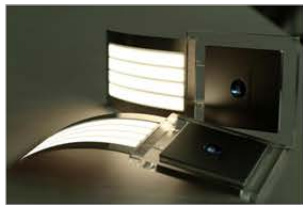


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Prototype



All-phosphorescent OLED with world-record performance @SID2007



All-phosphorescent OLED by R2R solution-process @Light+Building2010



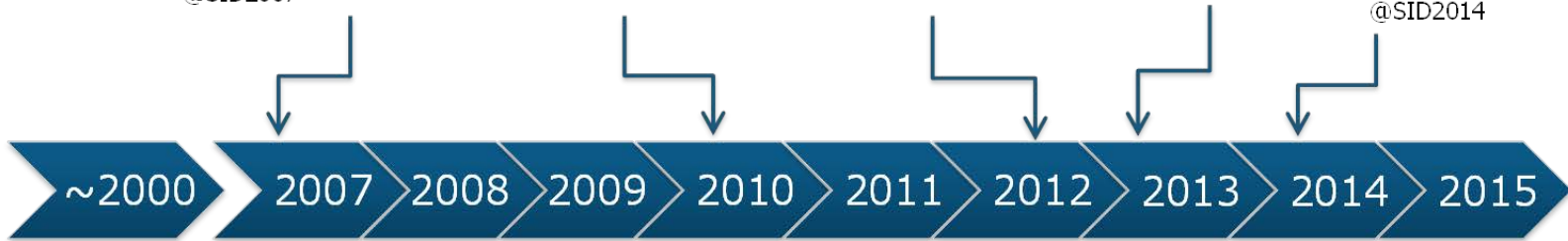
Large area OLED using new printable anode @CEATEC Japan 2012



Flexible OLED panel demonstration @LIGHTING FAIR 2013



The world's most efficient OLED lighting panel @SID2014



Product & Business

Symfos



World's first all-phosphorescent white OLED product™ Symfos OLED-010K™



Mass production for plastic substrate flexible OLED lighting panel

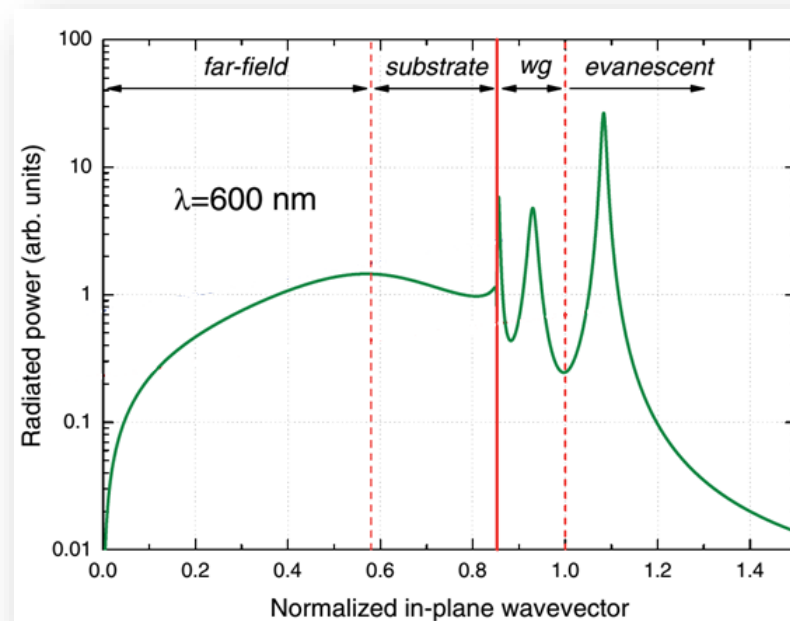
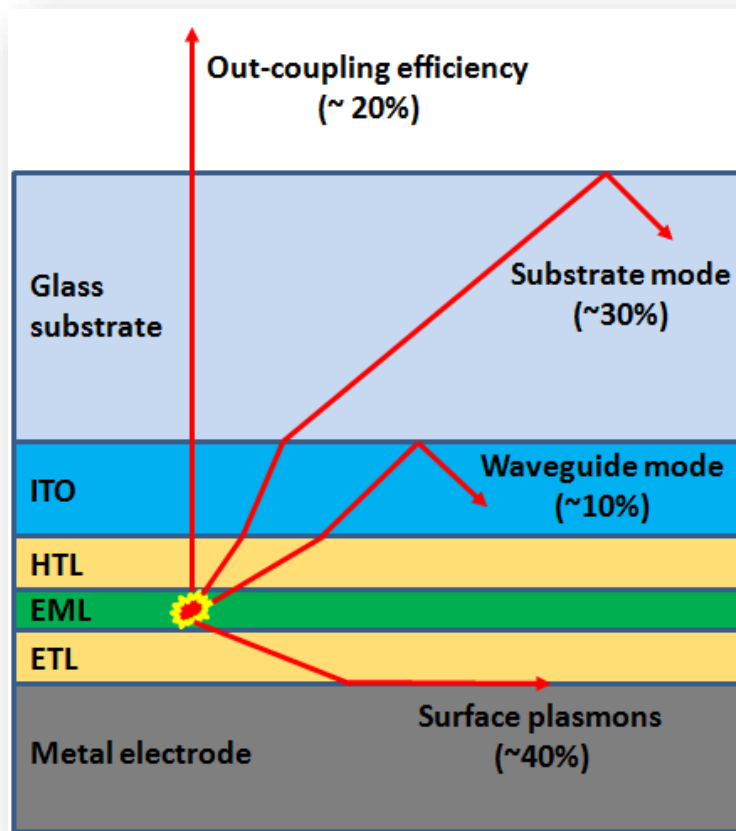


World's first flower illumination

Multilayer structure and light out-coupling of OLED



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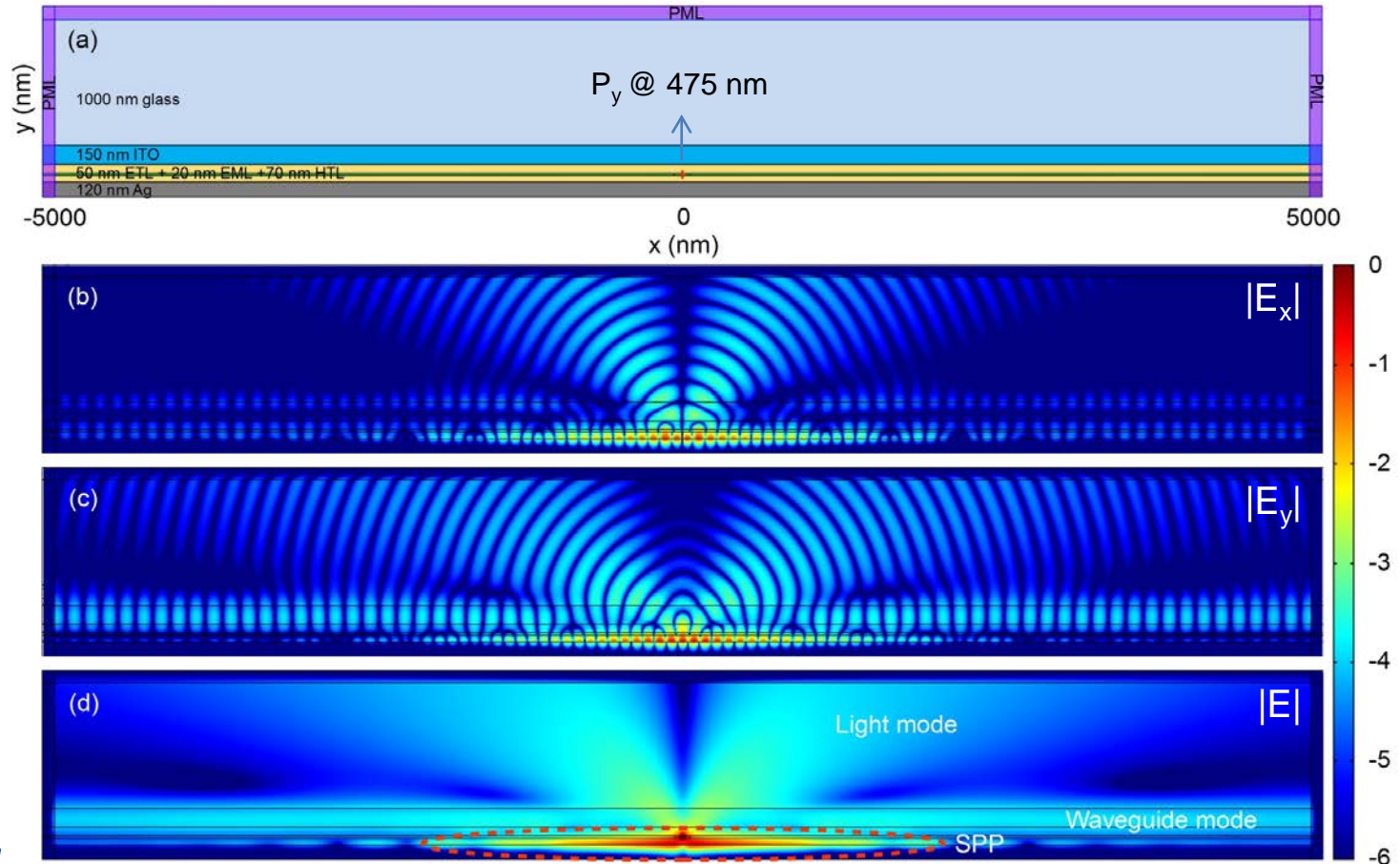


Typical power distribution spectrum of an OLED viewed in the k-space*

Visualizing field distribution in OLED in real space



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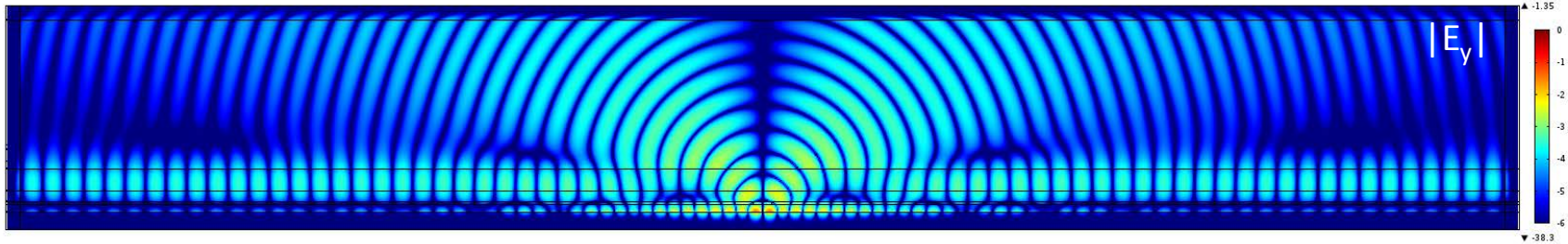


Visualizing field distribution in OLED in real space

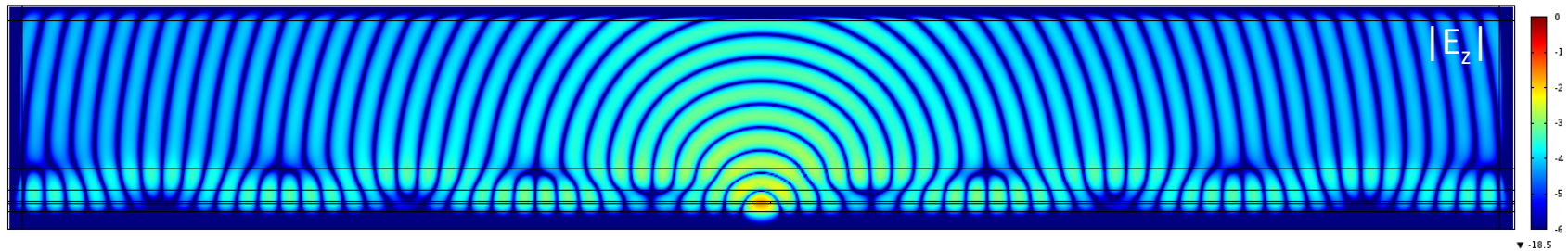


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$P_x @ 475 \text{ nm}$



$P_z @ 475 \text{ nm}$

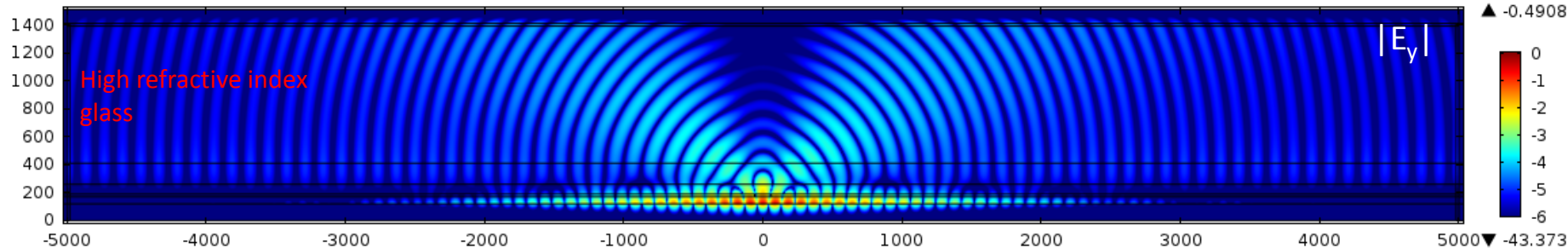
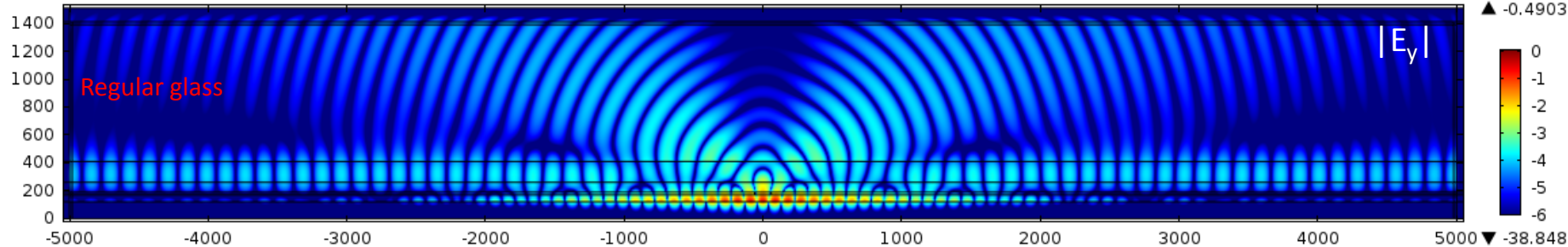


- SPP coupling is less for horizontally oriented dipole emission.
- No SPP coupling for s-polarized case in 2D.

Reducing waveguide mode by high index substrate



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MULTIPHYSICS

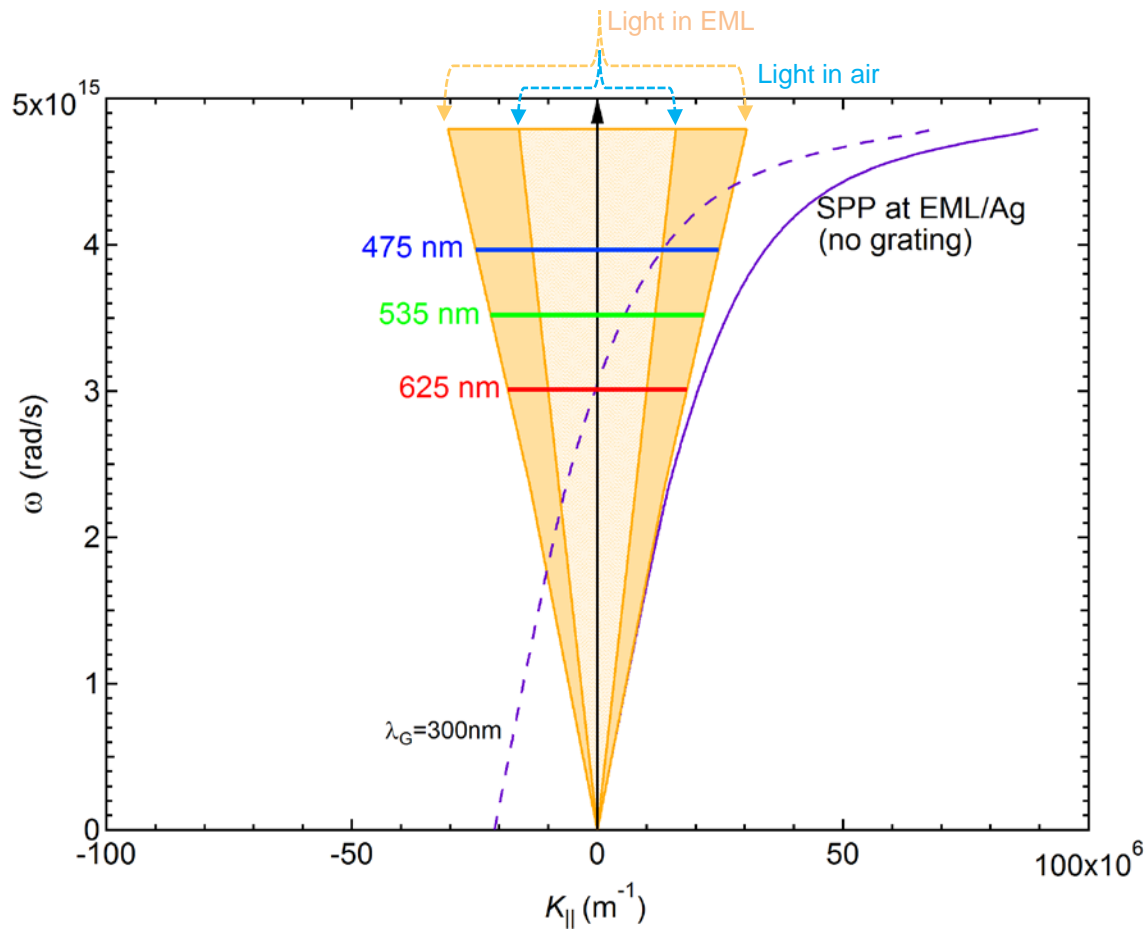


- P_y @ 475 nm.
- Strategy of enhancing light extraction efficiency of OLED:
plasmon mode → waveguide mode → substrate mode → air mode.

Reducing SPP coupling by nanograting electrode



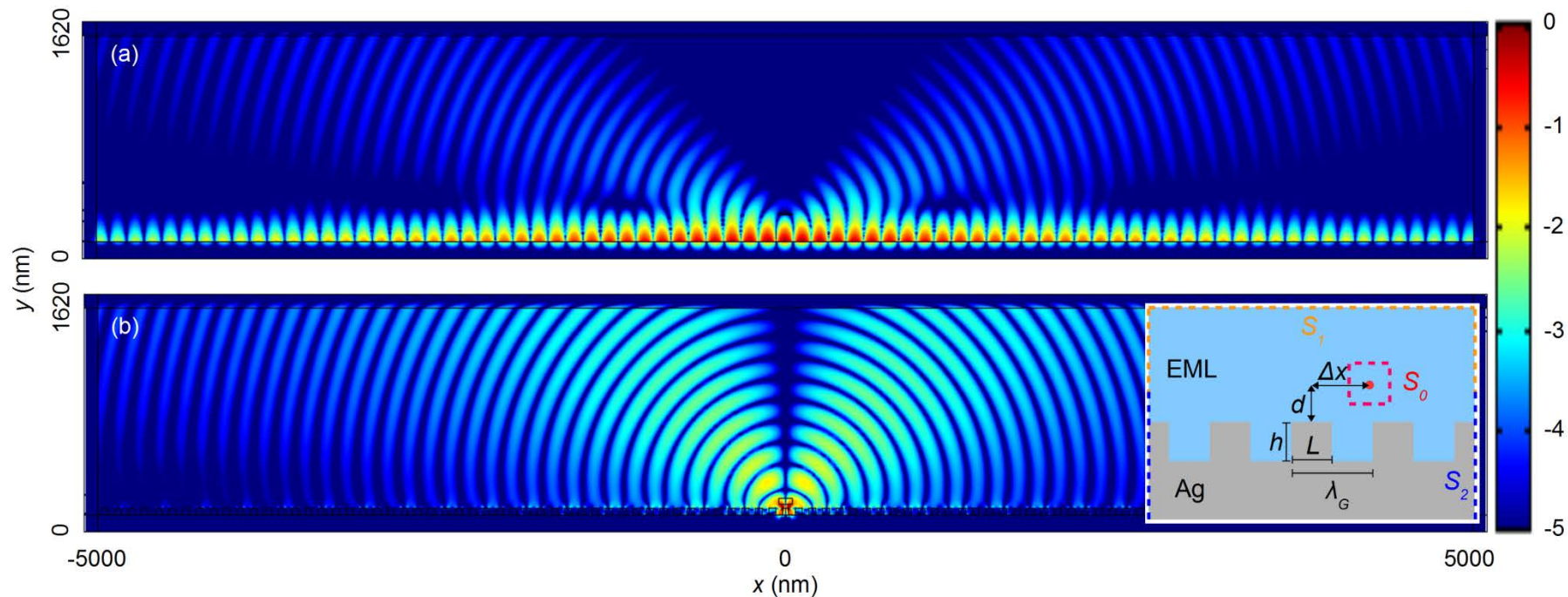
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Reducing SPP coupling by nanograting electrode



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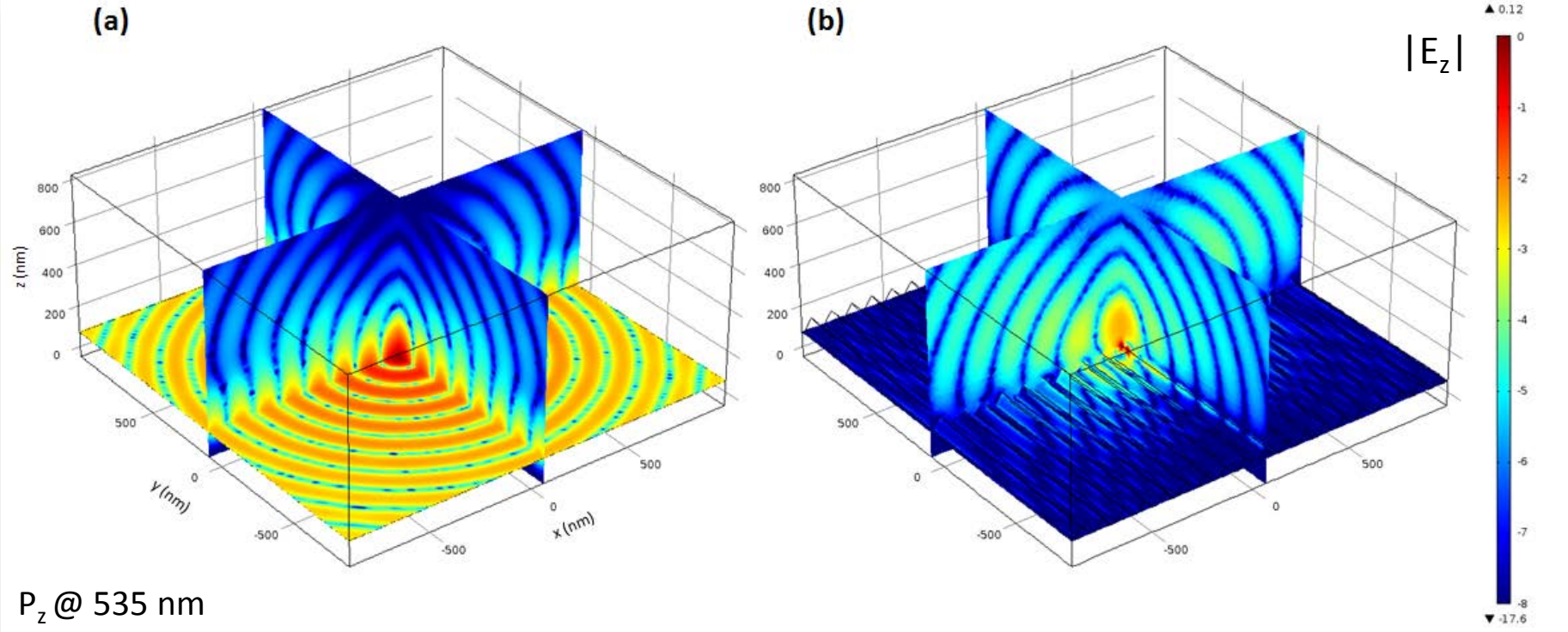


- Simplified model – Ag/EML two layer.
- P_y @ 535 nm.
- Grating: $\lambda_G = 100$ nm, $L = 50$ nm, $h = 50$ nm, $d = 50$ nm, $\Delta x = 0$.

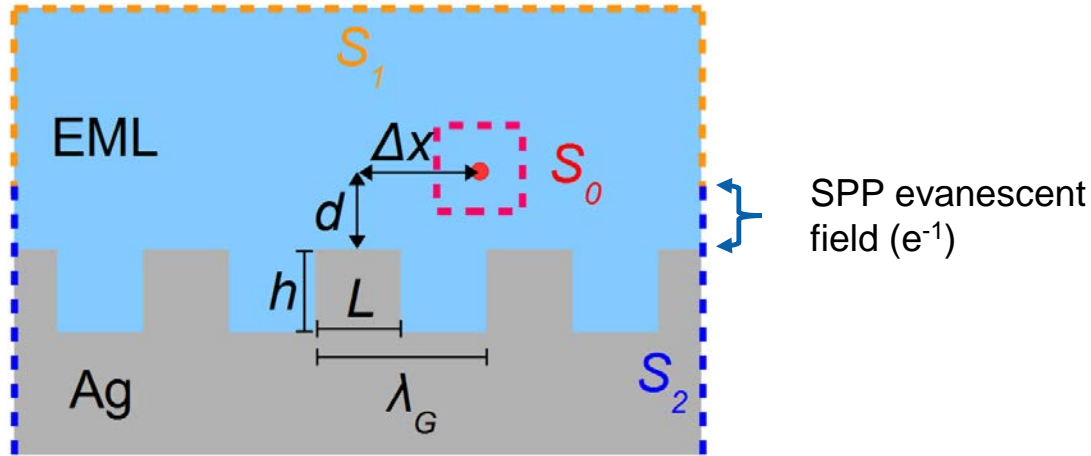
Reducing SPP coupling by nanograting electrode



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- 3D capable, but memory intensive and time-consuming

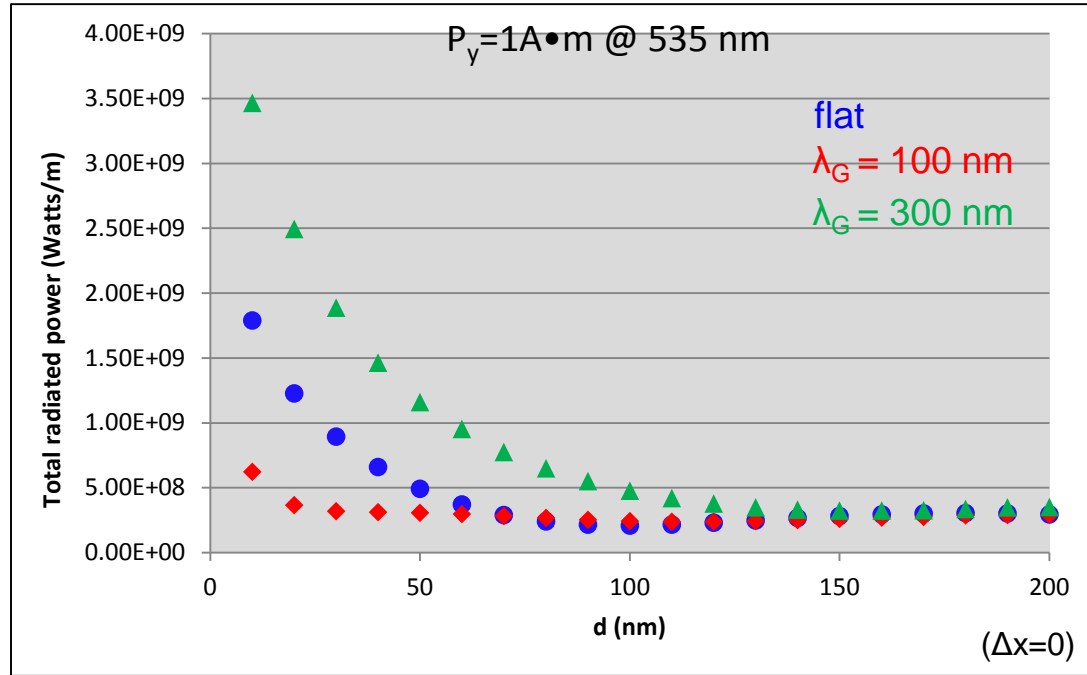


$$P_{total} = \int (\vec{E} \times \vec{H}) \cdot d\vec{S}_0$$

$$P_{light} = \int (\vec{E} \times \vec{H}) \cdot d\vec{S}_1$$

$$P_{plasmon} = \int (\vec{E} \times \vec{H}) \cdot d\vec{S}_2 + \int (\vec{J} \cdot \vec{E}) \cdot dV_{Ag}$$

$$Plasmon \text{ loss } (\%) = P_{plasmon} / P_{total}$$



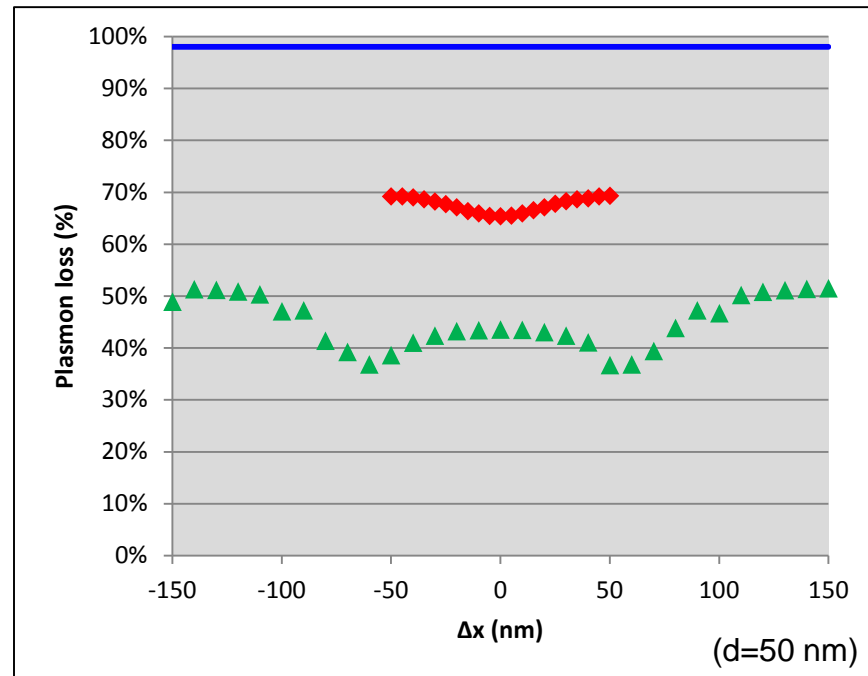
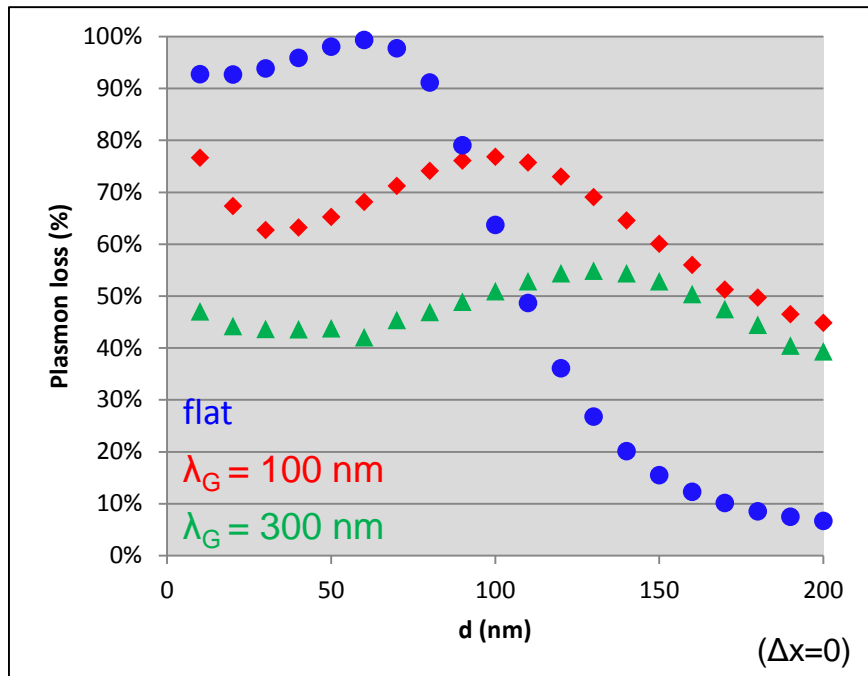
- Total emission power correlates with the decay rate of the molecular emitter and the internal quantum efficiency (IQE) of OLED.
- For all-phosphorescent OLED, the IQE is $\sim 100\%$; only the percentage of plasmon loss is concerned.

Plasmon loss – vertical dipole



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P_y @ 535 nm

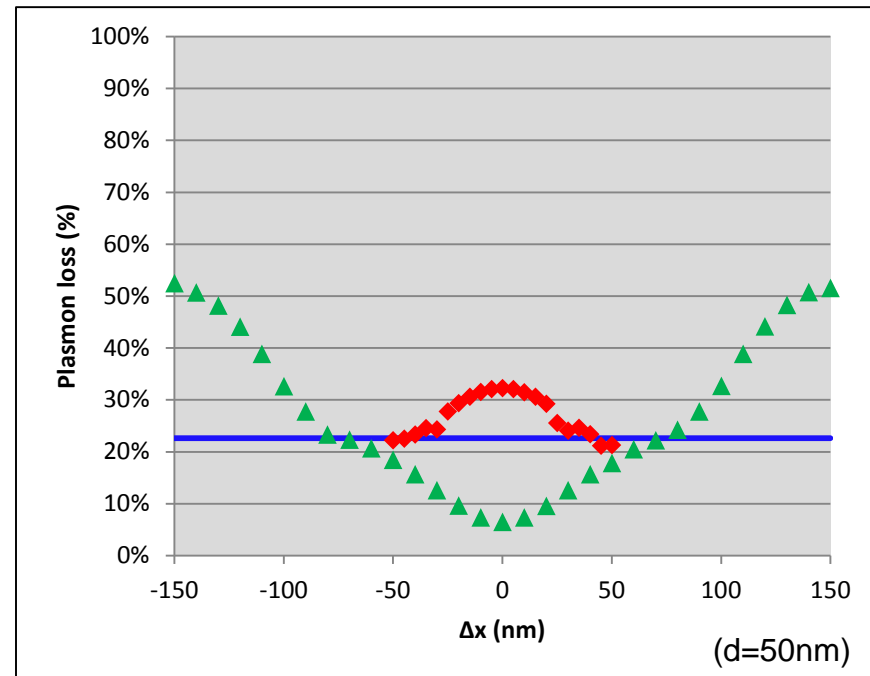
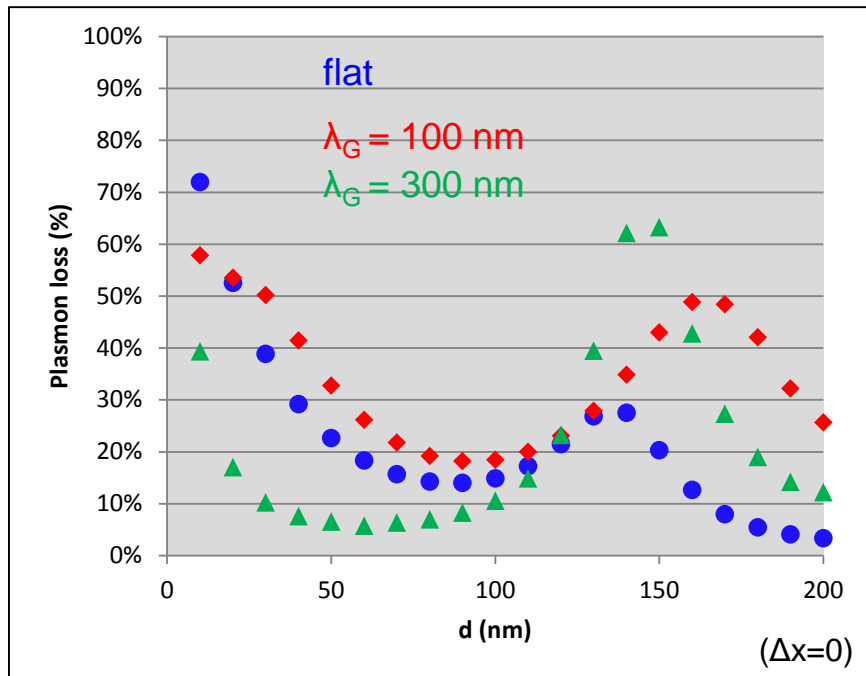


Plasmon loss – horizontal dipole



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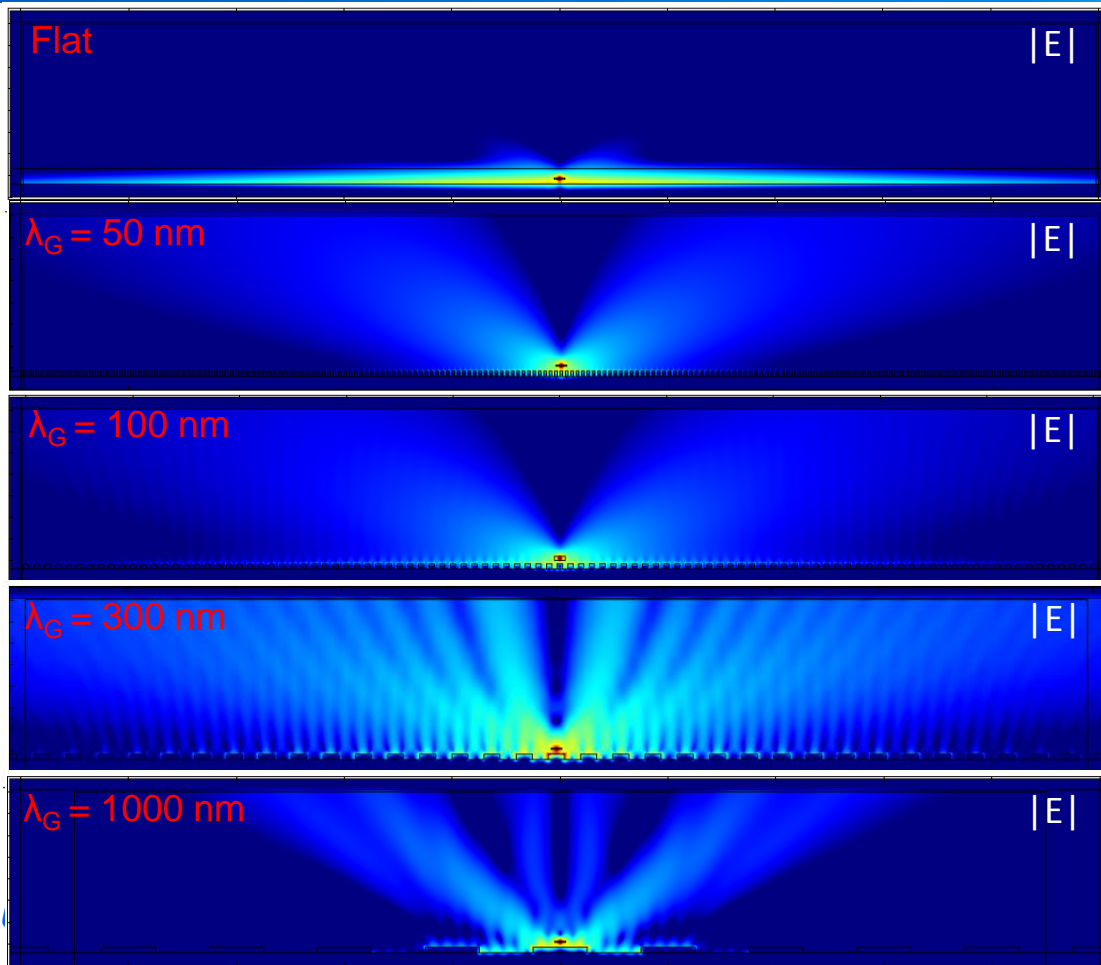
P_x @ 535 nm



Effect on emission pattern

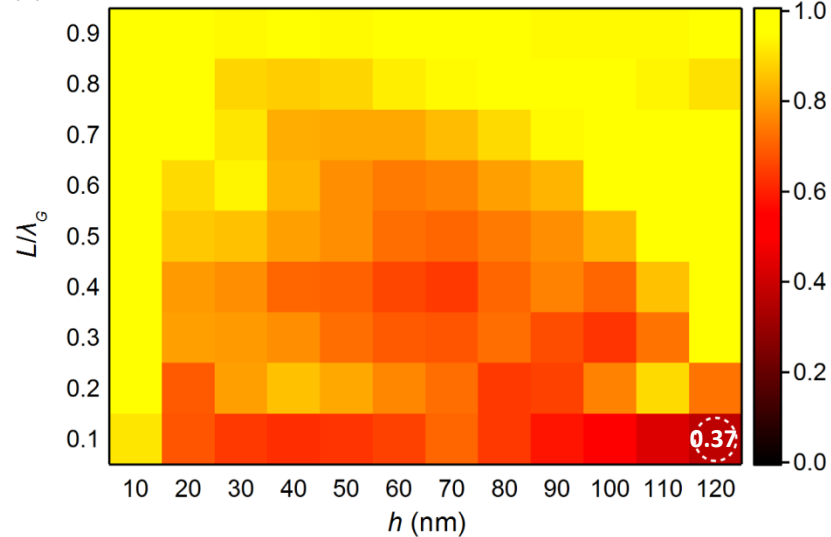


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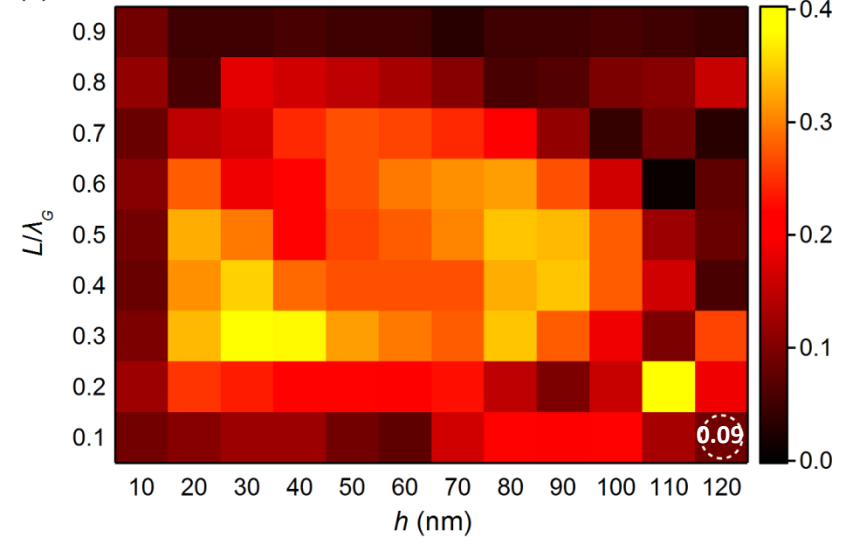


- P_y @ 535 nm.
- $\Delta x = 0$, $d = 50 \text{ nm}$,
 $h = 50 \text{ nm}$, $L/\lambda_G = \frac{1}{2}$.
- Large grating may lead to structured directional emission.
- Subwavelength grating – metasurface.

(a) Relative plasmon loss



(b) SD of wavelength averaging



- Relative ratio of plasmon loss - grating with respect to flat.
- $\lambda_G = 100\text{nm}$, $d = 50\text{ nm}$.
- Average of 2 horizontal positions: $\Delta x = 0$, $\Delta x = \lambda_G/2$.
- Average of P_x and P_y .
- Average of 3 emission wavelength: 475 nm, 535 nm, 625nm.
- **COMSOL Multiphysics® Cluster Sweep – parallel!**

- ❑ Mode distribution and plasmon coupling effect in OLED were modeled using COMSOL Multiphysics®, which can simulate the optical effect caused by arbitrary subwavelength nanostructures.
- ❑ Reduction of plasmon loss in OLED by ~ 50% over broadband emission is promising by nanostructured metal cathode.

Acknowledgement



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OLED group

Simulation group

Thank you for attention